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**Keywords:** the device, assemblage, microelectronics, the soldering, quality

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**Keywords:** MEMS, electric capacitance, plane capacitor, fringing field effect, analytical expressions

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**Keywords:** inertial navigation, error model, micromechanical gyro, small-sized two-axis test table

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**Keywords:** positioning and vibration isolation systems, magneto- and electrorheological fluids and elastomers, viscosity

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**Keywords:** field emission, cathodoluminescent light sources, electron optics, carbon materials

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